

-	66	((system.ti. and(regulat\$3)) and(memory with synchronous near dynamic)) and (((system.ti. and(regulat\$3)) and(memory with synchronous near dynamic)) and(dynamic near random near access near memory))	USPAT; US-PGPUB; JPO	2004/10/20 08:52
-	1	((((capacitor.ti. and(terminal\$1 with first near polarity)) and(terminal\$1 with second near polarity)) and(motherboard)) and(chip)) and(memory	USPAT; US-PGPUB; JPO	2004/10/20 08:52
-	0	361/\$.ccls. and (((system.ti. and(regulat\$3)) and(memory with synchronous near dynamic)) and (((system.ti. and(regulat\$3)) and(memory with synchronous near dynamic)) and(dynamic near random near access near memory)))	USPAT; US-PGPUB; JPO	2004/10/20 08:53
-	15	((((system.ti. and(regulat\$3)) and(memory with synchronous near dynamic)) and (((system.ti. and(regulat\$3)) and(memory with synchronous near dynamic)) and(dynamic near random near access near memory))) and(capacitor)	USPAT; US-PGPUB; JPO	2004/10/20 09:12
-	671	electronic.ti. and(motherboard)	USPAT; US-PGPUB; JPO	2004/10/20 09:13
-	38	electronic.ti. and(motherboard)) and(voltage near regulat\$3	USPAT; US-PGPUB; JPO	2004/10/20 09:13
-	22	((electronic.ti. and(motherboard)) and(voltage near regulat\$3)) and(capacitor)	USPAT; US-PGPUB; JPO	2004/10/20 09:13
-	19	((electronic.ti. and(motherboard)) and(voltage near regulat\$3)) and(capacitor)) and(chip)	USPAT; US-PGPUB; JPO	2004/10/20 09:13
-	15	(((((electronic.ti. and(motherboard)) and(voltage near regulat\$3)) and(capacitor)) and(chip)) and(memory	USPAT; US-PGPUB; JPO	2004/10/20 09:14
-	15	(((((electronic.ti. and(motherboard)) and(voltage near regulat\$3)) and(capacitor)) and(chip)) and(memory)) and(bus)	USPAT; US-PGPUB; JPO	2004/10/20 09:15
-	65	capacitor.ti. and(motherboard)	USPAT; US-PGPUB; JPO	2004/10/20 09:15
-	42	capacitor.ti. and(motherboard)) and(memory	USPAT; US-PGPUB; JPO	2004/10/20 09:15
-	40	((capacitor.ti. and(motherboard)) and(memory)) and(chip)	USPAT; US-PGPUB; JPO	2004/10/20 09:15
-	15	((capacitor.ti. and(motherboard)) and(memory)) and(chip)) and(bus)	USPAT; US-PGPUB; JPO	2004/10/20 09:52
-	4	multilayer with capacitor.ti. and(pcb)	USPAT; US-PGPUB; JPO	2004/10/20 10:29
-	4047	memory with synchronous near dynamic near random near access	USPAT; US-PGPUB; JPO	2004/10/20 10:30
-	760	system.ti. and (memory with synchronous near dynamic near random near access)	USPAT; US-PGPUB; JPO	2004/10/20 10:30
-	8	361/\$.ccls. and (system.ti. and (memory with synchronous near dynamic near random near access))	USPAT; US-PGPUB; JPO	2004/10/20 10:34
-	0	multilayer with capacitor.ti. and(SDRAM)	USPAT; US-PGPUB; JPO	2004/10/20 10:34
-	56	capacitor.ti. and(SDRAM)	USPAT; US-PGPUB; JPO	2004/10/20 10:47

-	32	capacitor.ti. and(memory with SDRAM)	USPAT; US-PGPUB; JPO	2004/10/20 14:16
-	105	cylindrical with capacitor.ti.	USPAT; US-PGPUB; JPO	2004/10/20 14:17
-	15	cylindrical with capacitor.ti.) and(terminal	USPAT; US-PGPUB; JPO	2004/10/20 14:17
-	18	cylindrical with capacitor.ti.) and(terminal\$1	USPAT; US-PGPUB; JPO	2004/10/20 14:20
-	3	cylindrical with capacitor.ti.) and(polarity	USPAT; US-PGPUB; JPO	2004/10/20 16:52
-	1	"20020168510"	USPAT; US-PGPUB; JPO	2004/10/21 07:27
-	5816	capacitor.ti. and(terminal)	USPAT; US-PGPUB; JPO	2004/10/21 10:02
-	18	capacitor.ti. and(terminal)) and(electrical near plate	USPAT; US-PGPUB; JPO	2004/10/21 07:37
-	1		USPAT	2004/10/21 07:32
-	1		USPAT	2004/10/21 07:32
-	1		USPAT	2004/10/21 07:32
-	1		USPAT	2004/10/21 07:32
-	1		USPAT	2004/10/21 07:32
-	1		USPAT	2004/10/21 07:32
-	1		USPAT	2004/10/21 07:32
-	2	low with inductance with capacitor.ti.) and(central near terminal\$1	USPAT; US-PGPUB; JPO	2004/10/21 07:38
-	54	low with inductance with capacitor.ti.	USPAT; US-PGPUB; JPO	2004/10/21 07:39
-	6957	capacitor.ti. and(terminal\$1)	USPAT; US-PGPUB; JPO	2004/10/21 10:03
-	92	capacitor.ti. and(terminal\$1)) and(film near foil	USPAT; US-PGPUB; JPO	2004/10/21 10:27
-	0	wound with capacitor.ti.) and(PWB with solder near ball\$1	USPAT; US-PGPUB; JPO	2004/10/21 10:28
-	0	wound with capacitor.ti.) and(solder near ball\$1	USPAT; US-PGPUB; JPO	2004/10/21 10:29
-	2	wound with capacitor.ti.) and(ball\$1	USPAT; US-PGPUB; JPO	2004/10/21 10:29
-	98	wound with capacitor.ti.	USPAT; US-PGPUB; JPO	2004/10/21 10:37
-	13	liu adj tao.in.	USPAT; US-PGPUB; JPO	2004/10/21 10:45
-	149	361/301.5 and(capacitor)	USPAT; US-PGPUB; JPO	2004/10/21 13:04
-	25156	printed near wiring near board	USPAT; US-PGPUB; JPO	2004/10/21 13:05
-	128	capacitor.ti. and printed near wiring near board	USPAT; US-PGPUB; JPO	2004/10/21 14:53
-	0	micromachi\$3 with varactor.ti.	USPAT; US-PGPUB; JPO	2004/10/21 14:54

-	0	micro near machin\$3 with varactor.ti.	USPAT; US-PGPUB; JPO	2004/10/21 14:54
-	0	micromachin\$3 with varactor.ti.	USPAT; US-PGPUB; JPO	2004/10/21 15:32
-	1	varactor.ti. and(deflecting near beam)	USPAT; US-PGPUB; JPO	2004/10/21 15:26
-	27	varactor.ti. and(beam)	USPAT; US-PGPUB; JPO	2004/10/21 15:26
-	1	varactor.ti. and(beam)) and(path near plate\$1	USPAT; US-PGPUB; JPO	2004/10/21 15:26
-	12	varactor.ti. and(beam)) and(plate\$1	USPAT; US-PGPUB; JPO	2004/10/21 15:26
-	5	((varactor.ti. and(beam)) and(plate\$1)) and(vacuum)	USPAT; US-PGPUB; JPO	2004/10/21 15:27
-	1	micromachin\$3 with varactor\$1.ti.	USPAT; US-PGPUB; JPO	2004/10/21 15:33
-	130	wong near marvin.in.	USPAT; US-PGPUB; JPO	2004/10/21 16:08
-	1	6657525.pn.	USPAT; US-PGPUB; JPO	2004/10/21 16:14
-	7	MEMS.ti. and(deflecting near beam)	USPAT; US-PGPUB; JPO	2004/10/21 16:19
-	2	MEMS.ti. and(deflecting near beam)) and(plate\$1	USPAT; US-PGPUB; JPO	2004/10/21 16:19
-	0	((MEMS.ti. and(deflecting near beam)) and(plate\$1)) and(vacuum)	USPAT; US-PGPUB; JPO	2004/10/21 16:19
-	0	((MEMS.ti. and(deflecting near beam)) and(plate\$1)) and(airtight near vacuum)	USPAT; US-PGPUB; JPO	2004/10/21 16:20
-	0	MEMS.ti. and(airtight near vacuum)	USPAT; US-PGPUB; JPO	2004/10/21 16:20
-	0	microelectrochemical.ti. and(airtight near vacuum)	USPAT; US-PGPUB; JPO	2004/10/22 08:49
-	1	varactor with airtight near vacuum	USPAT; US-PGPUB; JPO	2004/10/21 17:00
-	7	"5978204"	USPAT; US-PGPUB; JPO	2004/10/21 16:49
-	477	mems.ti. and(beam)	USPAT; US-PGPUB; JPO	2004/10/21 17:02
-	248	mems.ti. and(beam)) and(plate\$1	USPAT; US-PGPUB; JPO	2004/10/21 17:01
-	126	((mems.ti. and(beam)) and(plate\$1)) and(cantilever\$2)	USPAT; US-PGPUB; JPO	2004/10/21 17:02
-	27	varactor.ti. and(beam)	USPAT; US-PGPUB; JPO	2004/10/21 17:03
-	0	varactor.ti. and(beam)) and(cantilever\$2	USPAT; US-PGPUB; JPO	2004/10/21 17:03
-	79	varactor and(cantilever\$2)	USPAT; US-PGPUB; JPO	2004/10/21 17:10

-	501	electrostatic and cantilever and RF	USPAT; US-PGPUB; JPO	2004/10/21 17:13
-	18	electrostatic and cantilever and RF) and(varactor	USPAT; US-PGPUB; JPO	2004/10/21 17:35
-	13	361/287 and(varactor)	USPAT; US-PGPUB; JPO	2004/10/22 07:15
-	791	361/\$.ccls. and(cantilever)	USPAT; US-PGPUB; JPO	2004/10/22 07:15
-	4	361/\$.ccls. and(cantilever)) and(actuator near plate	USPAT; US-PGPUB; JPO	2004/10/22 07:16
-	135	361/\$.ccls. and(cantilever)) and(actuator	USPAT; US-PGPUB; JPO	2004/10/22 07:36
-	10	varactor with package and(beam)	USPAT; US-PGPUB; JPO	2004/10/22 07:37
-	3	varactor with package and(cantilever)	USPAT; US-PGPUB; JPO	2004/10/22 07:40
-	66	varactor and(cantilever)	USPAT; US-PGPUB; JPO	2004/10/22 07:51
-	761	varactor and(beam)	USPAT; US-PGPUB; JPO	2004/10/22 07:52
-	42	varactor and(beam)) and(actuator	USPAT; US-PGPUB; JPO	2004/10/22 07:59
-	40	361/277 and(varactor)	USPAT; US-PGPUB; JPO	2004/10/22 08:05
-	6440	varactor	USPAT; US-PGPUB; JPO	2004/10/22 08:05
-	27	varactor.ti. and(beam)	USPAT; US-PGPUB; JPO	2004/10/22 08:08
-	3	varactor.ti. and(actuator)	USPAT; US-PGPUB; JPO	2004/10/22 08:42
-	30	361/278 and(varactor)	USPAT; US-PGPUB; JPO	2004/10/22 08:49
-	0	microelectrochemical.ti. and(cantilever)	USPAT; US-PGPUB; JPO	2004/10/22 08:49
-	4	microelectrochemical.ti.	USPAT; US-PGPUB; JPO	2004/10/22 08:50
-	22	MEMS.ti. and varactor	USPAT; US-PGPUB; JPO	2004/10/22 08:54
-	306	varactor.ti.	USPAT; US-PGPUB; JPO	2004/10/22 09:09
-	37	capacitor.ti. and(cantilever near beam)	USPAT; US-PGPUB; JPO	2004/10/22 09:12
-	8	capacitor.ti. and(cantilever near beam)) and(actuator	USPAT; US-PGPUB; JPO	2004/10/22 09:12
-	73	capacitor.ti. and(cantilever)	USPAT; US-PGPUB; JPO	2004/10/22 09:12
-	14	capacitor.ti. and(cantilever)) and(actuator	USPAT; US-PGPUB; JPO	2004/10/22 09:35

-	19	variable with capacitor.ti. and(cantilever)	USPAT; US-PGPUB; JPO	2004/10/22 09:37
-	29	variable with capacitor.ti. and(actuator)	USPAT; US-PGPUB; JPO	2004/10/22 09:46
-	344	361/277	USPAT; US-PGPUB; JPO	2004/10/23 11:17
-	36	variable with capacitor.ti. and(beam)	USPAT; US-PGPUB; JPO	2004/10/23 11:19
-	19	variable with capacitor.ti. and(cantilever)	USPAT; US-PGPUB; JPO	2004/10/23 11:21
-	15	361/287 and(cantilever)	USPAT; US-PGPUB; JPO	2004/10/23 11:25
-	30	361/287 and(actuator)	USPAT; US-PGPUB; JPO	2004/10/23 12:03
-	306	varactor.ti.	USPAT; US-PGPUB; JPO	2004/10/23 12:08
-	545	variable with capacitor.ti.	USPAT; US-PGPUB; JPO	2004/10/23 12:23
-	6	361/279 and(MEMS)	USPAT; US-PGPUB; JPO	2004/10/23 12:24
-	4	361/279 and(varactor)	USPAT; US-PGPUB; JPO	2004/10/23 12:26
-	2861	MEMS and vacuum	USPAT; US-PGPUB; JPO	2004/10/23 12:26
-	410	(MEMS and vacuum) and cantilever	USPAT; US-PGPUB; JPO	2004/10/23 12:29